

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Docket No: **Q77911**

Hideya TAKEO et al

Conf. No.: **3651**

Appln. No.: **10/684,708**

Group Art Unit: **2624**

Filed: **October 15, 2003**

Examiner: **Motsinger, S.**

For: **ABNORMAL PATTERN CANDIDATE DETECTION
PROCESSING METHOD AND SYSTEM**

AMENDMENT UNDER 37 C.F.R. § 1.114(c)

MAIL STOP AF

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated June 22, 2007, please amend the above-identified application as follows on the accompanying pages.

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